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978-1-107-40835-7 - Artificially Induced Grain Alignment in Thin Films: Materials Research Society Symposium Proceedings: Volume 1150

Editors: Vladimir Matias, Ruben Hühne, Seung-Hyun Moon and Robert Hammond

Table of Contents

[More information](#)

Preface	ix
Acknowledgments	xi
Materials Research Society Symposium Proceedings.....	xii

MILESTONES IN IBAD TEXTURING

* Inducing Grain Alignment in Metals, Compounds and Multicomponent Thin Films	3
James M.E. Harper	
* Development of IBAD Process for Biaxial Texture Control of RE-123 Coated Conductors	15
Yasuhiro Iijima	
From IBM (Harper) to Stanford, From IBAD-YSZ to ITaN-MgO	25
Robert H. Hammond	

IBAD TEXTURING

* Investigation of Early Nucleation Events in Magnesium Oxide During Ion Beam Assisted Deposition	37
James R. Groves, Robert H. Hammond, Raymond F. DePaula, and Bruce M. Clemens	
* Generating MgO Single- and Bi-Crystal Templates on Hard and Soft Substrates Using Ion Beam Assisted Texturing Process	49
Judy Wu, Rongtao Lu, and Ronald Vallejo	
Ion-Beam Assisted Pulsed Laser Deposition of Textured Transition-Metal Nitride Films	59
Ruben Hühne, Martin Kidszun, Konrad Güth, Franziska Thoss, Bernd Rellinghaus, Ludwig Schultz, and Bernhard Holzapfel	

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Table of Contents

[More information](#)

* Formation of Biaxial Crystalline Texture by Oblique Ion Bombardment.....	65
Paul Berdahl, Ronald P. Reade, and Richard E. Russo	
* Aligned-Crystalline Si Films on Non-Single-Crystalline Substrates	73
Alp Findikoglu, Terry Holesinger, Alyson Niemeyer, Vladimir Matias, and Ozan Ugurlu	
Development of Conducting Buffer Architectures Using Cube Textured IBAD-TiN Layers	85
Ruben Hühne, Konrad Güth, Martin Kidszun, Rainer Kaltofen, Vladimir Matias, John Rowley, Ludwig Schultz, and Bernhard Holzapfel	
Texture Evolution in Ion-Beam-Assist Deposited MgO	91
Vladimir Matias, Marcel Hoek, Jens Hänisch, and Alp Findikoglu	
ROUND TABLE DISCUSSION: Texturing Mechanisms in Thin Films	99

IBAD LONG LENGTH APPLICATION

* IBAD-MgO Architecture at SRL for Long Length IBAD/PLD Coated Conductors	111
Yutaka Yamada, Seiki Miyata, Masateru Yoshizumi, Hiroyuki Fukushima, Akira Ibi, Teruo Izumi, Yuh Shiohara, Takeharu Kato, and Tsukasa Hirayama	
* In-Plane Texturing of Buffer Layers by Alternating Beam Assisted Deposition: Large Area and Small Area Applications	117
Alexander Usoskin and Lutz Kirchhoff	
High Yield and High Throughput Reactive IBAD MgO Process for Long-length, HTS Wire Production at SuperPower	123
Xuming Xiong, Karol Zdun, Sunjing Kim, Andrei Rar, Senthil Sambandam, Robert Schmidt, Yimin Chen, Kenneth Lenseth, and Venkat Selvamanickam	

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Table of Contents

[More information](#)**TEXTURING BY OTHER TECHNIQUES**

Abnormal Grain Growth Behavior in Nanostructured Al Thin Films on SiO₂/Si Substrates	133
Flavia P. Luce, Paulo Fichtner, Luiz F. Schelp, and Fernando Zawislak	
* Artificial Grain Alignment of Organic Crystalline Thin Films	139
Toshihiro Shimada	
* Inclined Substrate Deposition of Biaxially Textured Magnesium Oxide Films	151
Beihai Ma, U. (Balu) Balachandran, Rachel E. Koritala, and Dean J. Miller	
Low-Temperature Selective Growth of Heteroepitaxial α-Al₂O₃ Thin Films on a NiO Layer by the Electron-Beam Assisted PLD Process	167
Makoto Hosaka, Yasuyuki Akita, Yuki Sugimoto, Yushi Kato, Yusaburo Ono, Akifumi Matsuda, Koji Koyama, and Mamoru Yoshimoto	
Intensity-Modulated Excimer Laser Annealing to Obtain (001) Surface-Oriented Poly-Si Films on Glass: Molecular Dynamics Study	173
Norie Matsubara, Tomohiko Ogata, Takanori Mitani, Shinji Munetoh, and Teruaki Motooka	
Crystallization Processes of Amorphous Si During Excimer Laser Annealing in Complete-Melting and Near-Complete-Melting Conditions: A Molecular Dynamics Study	179
Tomohiko Ogata, Takanori Mitani, Shinji Munetoh, and Teruaki Motooka	

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Table of Contents

[More information](#)

Carbon Nanotube-Induced Changes of Crystal Growth in Polymer Films.....	185
Georgi Y. Georgiev, Yaniel Cabrera, Lauren Wielgus, Zarnab Iftikhar, Michael Mattera, Peter Gati, Austin Potter, and Peggy Cebe	
Author Index	191
Subject Index.....	193